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	Filing Date		2003-10-02	
	First Named Inventor	Yoshiyuki Abe		
	Art Unit	1796		
	Examiner Name	Mark T. Kopec		
	Attorney Docket Number	KAM 20.660		

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4	0793277	EP		1997-09-03	CANON KABUSHIKI KAISHA		<input type="checkbox"/>
5	0686982	EP		1995-12-13	HOYA CORPORATION		<input type="checkbox"/>
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	2	A.E. DELAHOY, et al., "Transparent and semitransparent conducting film deposition by reactive-environment, hollow cathod sputtering" Journal of Vacuum Science and Technology A. Vacuum, Surfaces and Films, June 28, 2005, pg(s) 1215-1220, Vol. 23, no. 4, American Institute of Physics, New York, NY U.S.	<input type="checkbox"/>
	3	I. SAFI, et al., "The properties of reactively-sputtered, stoichiometry-controlled and optimum-conductivity transparent indium oxide films as a function of their titanium, aluminum and zinc content; comparisons with the use of tin as a dopant", April 1999, vol. 343-344, pg(s) 115-118, Dept. of Physics, Loughborough University, Loughborough, UK.	<input type="checkbox"/>
	4	G. CAMPET, et al., "The electronic effect of T14+, ZR4+ and GE4+ dopings upon the physical properties of IN203 and SN-doped IN203 ceramics: application to new highly-transparent conductive electrodes", June 20, 1993, pg(s) 285-289, vol. B19, no. 3, Lausanne, CH	<input type="checkbox"/>
	5	E. HUSENOV, et al., "IR-detectors based on In203-anode oxide-CdxHg1-xTe" International Journal of Infrared and Millimeter Waves, September 2002, vol. 23, no.9, pg(s) 1337-1345, Plenum Publishing Corporation, U.S.	<input type="checkbox"/>
	6	F.L. SUTHERLAND, et al. "Preparation and properties of transparent conducting films of ZnO and In203", September 1, 1988, pg.(s) 172-175, vol. 3, no. 3, Chemtronics, Butterworth Scientific Ltd., Guildford, GB	<input type="checkbox"/>

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7	K.L. CHOPRA, et al."Transparent conductors a status review", January 1983, vol. 102, pg(s) 1-46, Elsevier-Sequoia, The Netherlands	<input type="checkbox"/>
8	Summons to attend oral proceedings pursuant to Rule 115(1) EPC dated December 28, 2007 for corresponding European Application EP 03 256 274	<input type="checkbox"/>
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